

Application Data Sheet

Application Information

Application Type::	Regular
Subject Matter::	National Phase
Suggested Group Art Unit::	N/A
CD-ROM or CD-R?::	None
Sequence submission?::	None
Computer Readable Form (CRF)?::	No
Title::	SUBSTRATE PROCESSING APPARATUS AND SEMICONDUCTOR DEVICE PRODUCING METHOD
Attorney Docket Number::	2342-0143PUS1
Request for Early Publication?::	No
Request for Non-Publication?::	No
Total Drawing Sheets::	8
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Naoharu
Family Name::	NAKAISO
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City of mailing address::	Tokyo
Country of mailing address::	Japan
Postal or Zip Code of mailing address::	164-8511

Correspondence Information

10/549933

JC17 Rec'd PCT/PTO 20 SEP 2005

Correspondence Customer Number:: 02292

Representative Information

Representative Customer Number:: 02292

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/011266	08/05/04

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2003-206526	08/07/03	Yes

Assignee Information

Assignee name:: HITACHI KOKUSAI ELECTRIC INC.
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